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## SEP 1 9 2005 8

Applicant:

Masashi GOTO et al.

Title:

DIELECTRIC FILM, ITS FORMATION METHOD,

SEMICONDUCTOR DEVICE USING THE DIELECTRIC

FILM AND ITS PRODUCTION METHOD

**Application No.:** 

10/726,870

Filing Date:

2 December, 2003

Examiner/Unit:

Dao H. Nguyen / 2818

Attorney Docket No.:

2204-011-03

## **CERTIFICATE OF MAILING**

I hereby certify that this communication, and any document being attached hereto,

is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail addressed to: MS Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450

on this 15<sup>th</sup> day of September, 2005.

RESPONSE TO RESTRICTION REQUIREMENT UNDER 37 CFR § 1.143

TO THE COMMISSIONER FOR PATENTS:

In response to the 23 August 2005 restriction requirement under 35 USC § 121, Applicants elect Group I: Claims 1-5 and 13-17. Please cancel Group II: Claims 6-12 and 18-25, without traverse.

The above response to restriction requirement should place the application in condition for allowance. Applicants respectfully request that a timely Notice of Allowance be issued in this case.

Respectfully submitted,

**GRAYBEAL JACKSON HALEY LLP** 

Stephen M. Evans

Attorney for Applicants

Registration No. 37,128 155 - 108<sup>th</sup> Avenue N.E. Suite 350

Bellevue, WA 98004-5973

Phone: (425) 455-5575 Fax: (425) 455-1046

E-Mail: sevans@graybeal.com

Enclosure: Return Postcard

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